

NEW MEASUREMENTS USING LIBERA-SPARK ELECTRONICS AT ESRF: THE HIGH-QUALITY PHASE-MONITOR AND THE SINGLE-ELECTRON

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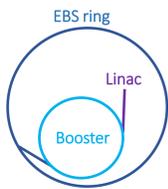
The ESRF complex

EBS parameters in User-mode:

- Circumference = 844 m
- Beam energy = 6 GeV
- Beam current = 200 mA
- Typical lifetime = 20h
- $3.5 \cdot 10^{12}$ electrons
- Revolution time = 2.816 μ s

At injection:

- 0.5 mA/shot
- 60-80% injection efficiency

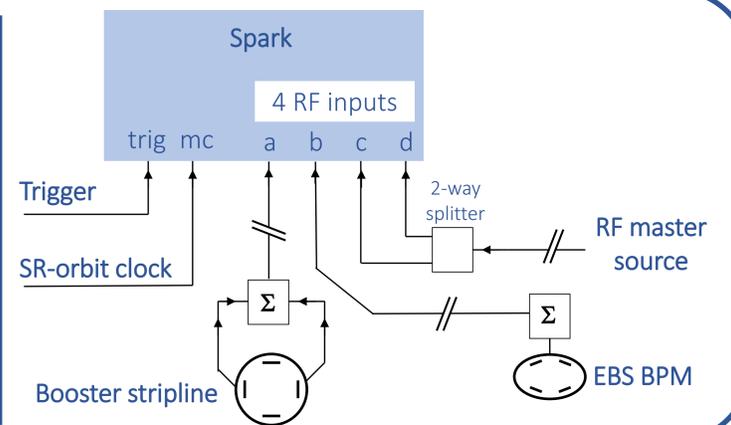


The high-quality phase-monitor

In TZ01 the new phase-monitor has been installed, based on Libera Spark Beam Position Monitor (BPM) electronics:

- Trigger
- A SR-orbit clock 355 kHz
- 4 RF inputs:
 - A Booster stripline
 - EBS BPM buttons
 - Master Source signals

The wobbly Phase-Locked Loop (PLL) affects all 4 RF inputs at the same way.

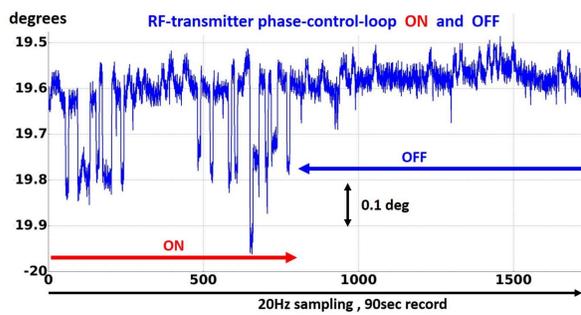


EBS phase measurements during operation

Phase between a EBS BPM and the RF master source

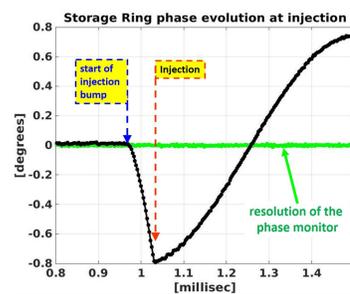
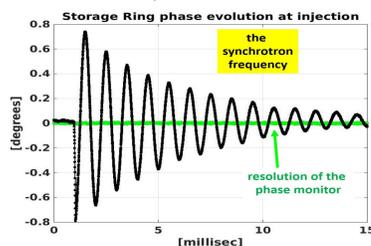
RF transmitter ON and OFF

RF-transmitter phase-control-loop ON and OFF

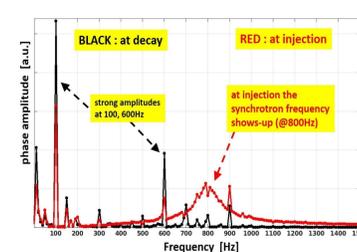


EBS phase measurements at injection

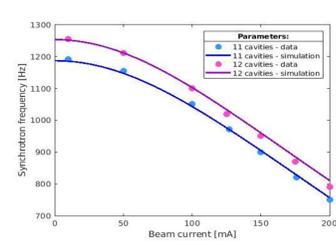
Time-resolved evolution:
damped oscillation



Frequency-domain:
Synchrotron radiation frequency \sim 1 kHz

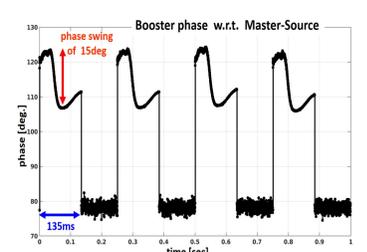


EBS synchrotron frequency
as a function of beam current

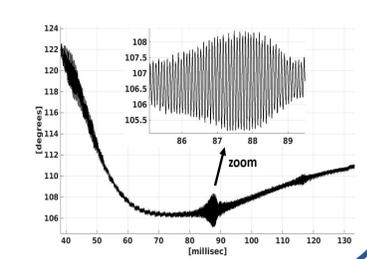


Booster phase measurements

Time-resolved evolution:
4 cycles of 250 ms



Additional fluctuations



The single-electron experiment

Single-electron injection and control:

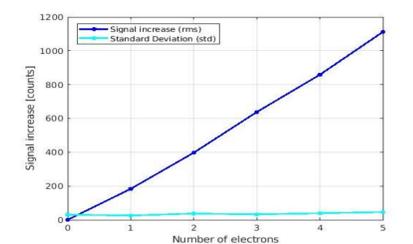
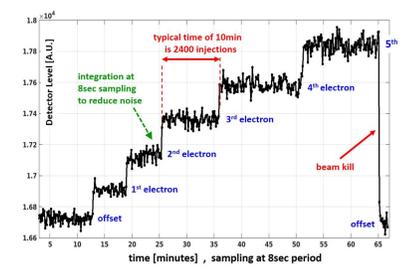
- All injection elements on (continuous injection), but **Linac gun off**
- Electrons generated at the Linac accelerating structures (2*100 MeV), called "dark current", that has no time structure, can fill any of 352 Booster buckets, around 100 electrons
- We reduce the dark-current flux by the insertion of 4 screens in the Transfer Line 2 (TL2)

The visible-light set-up:

- Cell 5 is equipped with an in-vacuum water-cooled Visible Light Mirror (VLM) to extract visible light for beam measurements
- Light source: 0.62 T bending magnet (BM)
- Additional optical elements are used (periscope, mirrors, 3-m achromat)
- A Photo-Multiplier Tube (PMT) and a Beam-Loss Monitor (BLM) electronics are used to acquire the signals

The single-electron measurement:

- PMT: at 1 M Ω impedance, 0.7 V gain, integrated mode, integrating time = 8 s
- Continuous injection
- One step visible every 10 minutes (\sim 2400 injections)
- 1-2-3-4-5 electrons were recorded in about 1h, then killed with the scraper
- Signal-to-Noise ratio > 6
- Around 200 counts per electron with this configuration



The impurity measurement:

Machine Development Time (MDT) with ID18 users to verify the bunch purity

Before optimization with the single-electron device:
➔ bunch impurities



Thanks to ID18 beamline, A. Chumakov et al.

After optimization:
➔ no impurities, but few peaks linked to cosmic-ray pollution



Thanks to ID18 beamline, A. Chumakov et al.

Conclusions

The phase-monitor can be used to follow-up the EBS phase, the Booster phase during each cycle, the evolution of synchrotron frequency with beam parameters and the cabling length variation with operation. It is useful during the User-mode operation, to identify issues from the frequency domain, and during the MDT studies, to cross-check the physics behaviour and to optimize the machine.

Secondly, the visible-light system has been exploited successfully for single-electron measurements. For the moment, the system is limited to low light levels, but the goal is to extend the S/N range by a better PMT and to implement a time-correlated-photon-counting system, to be able to determine also the position of these electrons. Afterwards, we want to improve the dynamic range of purity measurements with photon-to-pulse converters, with the aim of measuring the impurities also during USM operation.